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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph A. Wasshuber Art Unit: 2818
Serial No.: 10/714,366 Examiner: Nguyen, T.
Filing Date: 11/13/2003 Docket No.: TI-36280
Customer No.: 23494 Conf. No.: 1864

Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH PROCESSES

ELECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

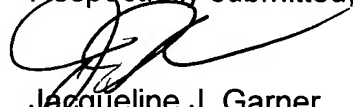
MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(A)
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12-2-05
Date Marianna Smith
Marianna Smith

Dear Sir:

With respect to the Restriction Requirement mailed on 11/21/2005, the Examiner has restricted the instant application to the invention of Species I (Claims 1-9, 21-23), or Species II (Claims 10-11), or Species III (Claim 24). In light of this, Applicant elects to pursue Species I, (Claims 1-9, 21-23) without traverse.

Respectfully submitted,


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